PTO/SB/21 (03-03)

Approved for use through 04/30/2003	. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT	OF COMMERCE

Vider the Paperwork Reduction Act of 1995, no persons	U.S. Patents are required to respond to a collection	t and Trademark Office; U.S. DEPARTMENT OF COMMERCE n of information unless it displays a valid OMB control number.
	Application Number	10/665,128
TRANSMITTAL TRANSMITTAL	Filing Date	September 22, 2003
FORM	First Named Inventor	Michael E. Thomas
(to be used for all correspondence after initial filing)	Art Unit	1742
	Examiner Name	Unknown
Total Number of Pages in This Submission	Attorney Docket Number	H0003933
ENCL	OSURES (Check all that	apply)
Fee Attached Amendment/Reply After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request	Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence Addre Ferminal Disclaimer Request for Refund CD, Number of CD(s)	After Allowance Communication to a Technology Center (TC) Appeal Communication to Board of Appeals and Interferences Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Other Enclosure(s) (please Identify below): 2 return receipt postcards; copy of non-U.S.cited references
under 37 CFR 1.52 or 1.53		
SIGNATURE O	F APPLICANT, ATTORNI	EY. OR AGENT
Firm Jennifer J. Taylor, Ph.D.; Reg. No. 4 Individual Signature Jennifer J. Taylor, Ph.D.; Reg. No. 4 January 9, 2004		
I hereby certify that this correspondence is being facsimile transfirst class mail in an envelope addressed to: Commissioner for	SATE OF TRANSMISSION Is mitted to the USPTO or deposited with Patents, Washington, DC 20231 on the	th the United States Postal Service with sufficient postage as
Typed or printed Jaime M. White		
Signature Na mel MA 147	shito,	Date January 9, 2004

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

To:

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

From:

Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)

Wells St. John P.S.

601 W. First Avenue, Suite 1300

Spokane, WA 99201-3828

Dear Sir:

The attached form PTO-1449 is submitted in compliance with 37 CFR § 1.56. Copies of the cited art are included with the exception of U.S. patents and published U.S. applications (1276 Off. Gaz. Pat. Off. 55, 05 August 2003). No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated:

By:

Jennifer J. Taylor, Ph.D

Reg. No. 48,711

Form PTO-1449

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTY.	DOCKET	NO.
LIO0020	22	

SERIAL NO. 10/665,128

LIST OF ART CITED BY APPLICANT

(Use several sheets if necessary)

APPLICANT Michael E. Thomas et al.

	18				FILING DATE September 22, 2003	GRO 1742	GROUP 1742				
14 1 2	U.S. PATENT DOCUMENTS saminer Document Date Name Class Subclass Filing Date										
*Examine Initial	, LS	Document Number	Date	Name		Class	Subclass		Filing Date If Appropriate		
3,0	АА	6,024,847	02-2000	Rosenberg et al.							
	AB	2,949,357	08-1960	Resnick			•	_			
	AC	5,171,379	12-1992	Kumar et al.	- 11						
	AD	5,403,458	04-1995	Hartig et al.			-				
	AE	5,209,835	05-1993	Makino et al.							
		<u> </u>	^	FOREIGN PATENT DOCUMENT	rs	R					
		Document	Date	Country		Class	Subclass	Trans	lation		
		Number				ļi		Yes	No		
	AF.	JP1092338	04/1989	Japan							
	AG	GB 810533	03/1959	GB							
	AH	JP57019372	02/1982	Japan							
	AI	JP200273623	10/2000	Japan							
1	AJ	SU1582683	09/1996	su							
1	AK	252,442	06/1960	AU							
	AL	55-179784	12/1980	Japan							
	AM	5-255843	10/1993	Japan				·			
		07	THER REFEREN	ICES (including Author, Title, Date,	, Pertinent Pages, Etc.)						
	AN			nd the Development of Local Orice. (Year is sufficiently early so that			lum, The Mi	nerals, Metals	&		
	AO	ASTM Standard Sp the month is not ar		antalum and Tantalum Alloy Plate	, Sheet, and Strip, pgs	. 558-561, 199	2. (Year s si	ufficiently earl	y so that		
	AP			on to Thorium and Thorium Comparity so that the month is not an		Encyclopedia o	of chemical T	Fechnology vol	. 22, pp.		
	AQ	Kumar, et al. "Effe 322, pgs. 413-422, 1	ct of Intermetalli 994. (Year is suf	ic Compounds of the Properties o	f Tantalum" Materials is not an issue.)	Research Soc	iety Symposi	um Proceeding	s, vol.		
	AR		Kirkbride et al., "The Effect of Yitrium on the Recrystallization and Grain Growth of Tantalum", J. Less-Common Metals, vol. 9, pp. 393-408, 1965. (Year is sufficiently early so that the month is not an issue.)								
	AS	National Research	Corporation Press	s Release, pgs. 1-4, July 1964.							
	AT	National Research	Corporation Data	a Sheet "SGS Tatalum", pgs. 1-7,	no date.						
	ΑÜ			ic Compounds of the Properties of the the month is not an issue.)	f Tantalum"Refractory	Metals & Ha	rd Materials,	vol. 12, pgs.	35-40,		
_	AV	Klein et al., "Inhon so that the month i		tures in Tantalum Sheets" Materials Science Forum, vol. 157-162, pgs. 1423, (1994).(Year is sufficiently ea.)							

EXAMINER

 $\mathbf{A}\mathbf{W}$

DATE CONSIDERED

Clark et al., "Influence of Transverse Rolling on the Microstructural and Texture Development in Pure Tantalum", Metallurgical Transactions, vol. 23A, pgs. 2183-2191, August 1992.

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-144	rm PTO-1449 U.S. DEPARTMENT OF COMMERC PATENT AND TRADEMARK OFFIC						ATTY, DOCKET 1 H0003933	IAL NO. 55,128				
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				ADEMARK OFFICE	APPLICANT	1	1 10/00	55,128				
OIPE						FILING DATE September 22, 2003		GRC 1742				
0						TENT DOCUMENTS	September 22, 2003		1742			
*Example:		Num	er nt	Date		Name		Class	Subclass	Filing If Appro		
- V	ADEM	5,939	7,788	08-1999	McTeer							
	АВ	4,903	5,117	02-1990	Okamoto	et al.						
	AC	6,521	,173	02-2003	Kumar et	t al.						
	AD	5,372	,659	12-1994	Lamaze e	et al.						
	AE	4,830	1,665	05-1989	Winand							
					FOREIGN I	PATENT DOCUMEN	TS					
		Docu	ıment	Date		Country		Class	Subclass	y, Vol. 10, pgs. 299-305, Ap. September 1993. Metallurgical Transactions		
		Numl							04001400			
		05005		0.450				†		163	140	
	AF	05097		04/93	JP (abstra	act)						
	AG		2 752 A1	08/91	EP			 	 	-		
	AH	0 928	3 977 A1	07/99	EP					ļ		
	ΑI	JP610	031992A	02/86	JP (abstra	act)			ļ	<u> </u>		
	AJ	wo	02/00959 A1	01/02	wo							
	AK	09-02	25562	28.01.1997	Јарап		•					
	AL	56071	1955A	15.06.1981	Japan							
	AM	02-17	73222	04.07.1990	Japan							
		·				ing Author, Title, Dat	e, Pertinent Pages, Etc.)	•	•	<u> </u>		
	AN Raabe, et al., "Texture and Microstructure of Rolled and Annealed Tantalum", Materials Science and Technology, Vol. 10, pgs. 299-305, Ap 1994.								-305, April			
	АО		Wright et al., "Text	ure Gradient Eff	ects in Tant	talum", International	Conference on Texture	es of Materia	ls, 7 pgs., Se	otember 1993.		
	AP					adient Effects on the so that the month i		of a Tantalum	n Plate", Mei	allurgical Trans	sactions A,	
	AQ		Clark et al., "Effect September 1991, pg		ariables on	Texture and Texture	Gradients in Tantalun	n", Metallurgi	cal Transacti	ons A, Vol. 22.	Α,	
	AR		Kumar et al., "Corr	osion Resistant	Properties of	f Tantalum" Corrosic	n 95, Paper No. 253, 1	4 pages. (No	date)			
,	AS											
	AT											
	AU						· ·					
-	AV											
	AW										-	
EXAMINER	_					DATE CONSIDE	RED					
			nce considered, whether		is in confor	mance with MPEP 6	9; Draw line through	citation if no	t in conforma	ance and not co	onsidered.	

Form PTO-144	19		-,			NT OF COMMERC		ATTY. DOCKET N	 о.			AL NO.	
مرور ا		PATENT AND TRADEMARK OFFICE LIST OF ART CITED BY APPLICANT						H0003933 APPLICANT			10/665	,128	
/3	PE	7	(Use several sheets i				-	Michael E. Thomas	et al.		77.01		
IAN 4 2 2004 9						_	FILING DATE September 22, 2003			GROU 1742	JP		
U.S. PATENT DOCUMENTS													
*Examiner Initial	کد	Desume	Date Name						Class	Sub	oclass	Filing If Appro	
	AA	5,110,63	37	05-1992	Ando								
	AB	6,451,40	02 B1	09-2002	Nee				!				
	AC	6,417,10	05 B1	07-2002	Shah et al	ıl.							
	AD												
	AE							•					
					FOREIGN F	PATENT DOCUM	ENT	rs					
		Docume		Date		Coun			Class	Sub	oclass	Transi	lation
		Number	r							L		Yes	No
	AF	EP0872:	572 A1	10-1998	EPO		_		:	$ldsymbol{f eta}$			
	AG	WO 98/	/49357	11-1998	PCT					<u> </u>			
	AH	WO 00/	/13235	09/03/2000	PCT					<u> </u>			
	AI	0812044	4 5	14/05/1996	Japan					<u> </u>	-	· ·	
	AJ	FR 2 5	FR 2 585 730 A1 08/01/1985 France						:	┞	\dashv		
—	AK	GB 2 2	202 237 A	21/09/1988	/1988 GB								
	AL	1107434	48	16/03/1999	Japan					⊢	\dashv		-
	AM 2000012539 14/01/2000 Japan												
			ОТ	HER REFEREN	CES (includir	ing Author, Title, D)ate,	Pertinent Pages, Etc.)					
	AN		Knotek et al., "The December 1988, pgs	Structure and C i. 481-488.	composition c	of Ti-Zr-N, Ti-Al-	Zr-N	N and Ti-Al-V-N Coati	ngs" Materia	als Sci	ence and	Engineering,	A105/106,
	AO												
	AP		Sakamoto et al., "Pi	reparation and N	Aicrostructure	e of Reactively Sp	putte	ered Ti _{1.x} Zr _x N Films" T	hin Solid Fil	lms 22	8, May	1993, pgs. 169	-172.
	AQ												
	AR												
	AS												
	AT												
	AU												
	ΑV												
	AW												
EXAMINER						DATE CONSID	ERI	ED					
			considered, whether		is in conform	mance with MPEP	, 609	9; Draw line through ci	tation if not	t in co	nforman	ce and not co	onsidered.